

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Shunpei Yamazaki et al.)
)
Serial No.: 09/544,801)
)
Filed: April 7, 2000)
)
For: Semiconductor Device And Method)
For Fabricating The Same)
)
Art Unit: 2826)
)
Confirmation No.: 1717)
)
Examiner: Fazli Erdem)

*Submission
w/ reply
Agent
01/28/08*

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT (J) AFTER ALLOWANCE

Sir:

In furtherance of the Notice of Allowance of October 10, 2007, please amend the above-identified application as follows: